

HYBRID PIXEL DETECTORS STATUS AND FUTURE CHALLENGES

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Outline

- Why hybrid pixels?
- Hybrid pixel detectors at LHC
- The Medipix2 chip
- The Timepix chip
- Imaging with the Timepix chip
- Spectroscopic X-ray imaging with Medipix2
- Limitations of Medipix2/Timepix
- Medipix3
- Future challenges for HEP and other fields
- Conclusions and future work





Hybrid-Pixel Detectors





Why use hybrid pixels?

- Any CMOS commercial process can be used
- The detector can be optimised for application
 - Si, thin EPI or 3D Si
 - GaAs, CdTe for mammography etc..
- Sometimes no sensor is used
 - Gas gain grid for gas detector readout
 - Micro channel plate
- Optimal signal to noise at high rates essential for clean pattern recognition in complicated high energy physics events





Noise hit rate for a discriminator



In a large bandwidth system (such as an HEP experiment) noise and threshold variation must be kept very far from the threshold to produce clean event information.

-5-



Hybrid pixels @ LHC - ATLAS

ATLAS Pixel Detector ~ 100M channels Half-shell of pixel layer 2 (interior):





The Alice Silicon Pixel Detector

2 layer barrel 10M pixels Total surface: ~0.24m² Power consumption ~1.5kW Evaporative cooling C₄F₁₀ Room temperature Material budget per layer ~1% X₀





The Alice Silicon Pixel Detector





Pixel block diagram



The Alice Silicon Pixel Detectorfinal checks of top half





The Alice Silicon Pixel Detector final installation





The Alice Silicon Pixel Detector – Detector Commissioning



SPD Online Event Display - Cosmic Run Self-triggered (FastOr) coincidence of top outer and bottom outer layer



ALICE Silicon Pixel Detector – first collisions



Detector triggered by pixel FAST-OR >=One hit per layer





Photon detector @ LHCb

 Hybrid Photon Detectors (HPD) developed in collaboration with industry Principal partner: DEP-Photonis for encapsulation of pixel anode in tube





8192-channel pixel chip $8 \times OR \rightarrow 1024$ pixels (500 \times 500 μm square)

5× demagnification from electron optics -> 2.5 mm at photocathode, as required



Fully equipped plane





Slide courtesy of R. Forty, T. Gys, K. Wyllie



LHCb RICH2 installation

 RICH2 constructed on surface, including alignment of optical elements
 Delicate transport (~ 1 km/h) to the LHCb cavern, 100 m underground





Slide courtesy of R. Forty, T. Gys, K. Wyllie



LHCb RICH – First rings

RICH2 HPD Panels with Pixels and CK Rings



Slide courtesy of R. Forty, T. Gys, K. Wyllie



Hybrid Pixels in High Energy Physics -Summary

- Hybrid pixels offer simultaneously:
 - Practically noise free images
 - Fast 'shutter' times
 - On pixel event selection
- Hybrid pixels have been used as vertex tracking detectors
 - Extremely good pattern recognition performance
 - Modest material budget
- Hybrid pixels have been used as photon RICH detectors
 - Very high pattern recognition performance



- Chip designed in same CMOS technology as Alice and LHCb
- Pixel shape now square 55μm pitch
- Matrix of 256 x 256 pixels
- In-pixel counter with 'camera' logic
 - Externally applied shutter
 - Window discriminator
 - 14-bit counter with stop at 12000
- Very high flux capability
 - $\geq 3 \text{ GHits/cm}^2$
- Frame-based readout



Two Collaborations

Medipix2

INFN and University of Cagliari CEA-LIST Saclav CERN Genève **University of Erlangen ESRE** Grenoble **University of Freiburg University of Glasgow IFAF** Barcelona **Mid Sweden University MRC-LMB** Cambridge **INFN and University of Napoli NIKHEF Amsterdam INFN and University of Pisa FZU CAS Prague IEAP CTU Prague SSL UC Berkeley University of Houston**

Medipix3

AMOLF Amsterdam Universidad de los Andes, Bogota **University of Bonn, Germany University of Canterbury NZ CEA-LIST Saclay CERN** Geneva **DESY Hamburg Diamond Light Source University of Erlangen ESRF** Grenoble **University of Freiburg University of Glasgow ITER Cadarache ISS University of Karlsruhe** Leiden University **Mid Sweden University NIKHEF Amsterdam IEAP CTU Praque SSL Berkeley VTT Microsystems**



Medipix2 Pixel Cell Schematic

Charge sensitive preamplifier with individual leakage current compensation 2 discriminators with globally adjustable threshold

3-bit local fine tuning of the threshold per discriminator

1 test and1 mask bit

External shutter activates the counter

13-bit pseudo-random counter







Medipix2 Cell Layout















High resolution X-ray imaging using a micro-focus X-ray source(1)







High resolution X-ray imaging using a micro-focus X-ray source(2)





-25-



MAXIPIX : a high frame rate pixel detector for SR experiments





noiseless (photon-counting)
high temporal resolution (fast readout)
high spatial resolution (small pixels)

Based on MEDIPIX2* photon-counting readout chip

•1280 x 256 pixels (5 readout chips)
•Pixel size 55 x 55 μm²
•6-20 keV range (500 μm Si sensor)
•> 10⁵ counts/pixel/s
•low and high energy thresholds
•0.20 ms readout dead time
•300 Hz frame rate (full frame)
•1500 Hz frame rate (256x256 pixels)

Main applications :

inelastic scattering
time-resolved XPCS
time-resolved SAXS, GISAXS
surface diffraction and scattering

Slide courtesy of C. Ponchut



Real high rate images





Application required development of a new fast readout system (ESRF Grenoble)

1 kHz frame rate imaging could be achieved turning chopper wheel

Slide courtesy of C. Ponchut



Low Energy Electron Microscopy





Medipix2 Images images

Graphene flakes

I. Sikharulidze, J-P Abrahams and co-workers 'Medipix2 applied to low energy electron microscopy', Ultramicroscopy 110 (2009) 33 - 35

-28-



TT to industry- PANalytical





Timepix chip

- Conserve dimensions and readout philosophy of Medipix2 (same CMOS technology)
- Requested by EUDet gas detector community
 - Add running clock during DAQ to obtain arrival time information wrt end of shutter
 - Added Time-over-Threshold capability



Timepix Schematic





Medipix2 vs Timepix Layout

Mpix2MXR20 layout







Timepix with 3-GEM detector



DESY testbeam in November 2006 (A.Bamberger, U. Renz, M.Titov)



Twin grid on Timepix





Developed by H. Van Der Graaf and co-workers

-34-



Developing a TimePix-Based Dosimeter for Space Radiation



- The University of Houston Medipix Group is working with NASA to develop a TimePix-based dosimeter for Space Radiation Applications...
- Such a device must be able to detect and measure all of the components of the Space Radiation Environment, which includes Energetic Heavy lons...
- Data have been taken with Heavy Ion beams at the HIMAC Facility in Japan...

Penetrating Heavy Ion Charge and Velocity Discrimination with a TimePix-based Si Detector





L. Pinsky and co-workers, Univ. Houston, USA



Tracks of 85 degree incident Si at 800 MeV/nuc moving from left to right





-36-



K-edge imaging





Univ. Canterbury, NZ Mars bio-imaging Small animal CT



Iodine: Pulmonary circulation
Barium: Lung
Bone: normal structure
4 energy CT and PCA





Spectral enhancement





Butler, A., et al., *Processing of spectral X-ray data with principal components Analysis*, IWORID 2009, Prague



CERN@school



Simon Langton School, Canterbury, England



Performance of Medipix2/Timepix

- Single photon counting provides excellent noise free images
- Ideal in photon starved situations
- Spectroscopic X-ray imaging possible
- Many different application both foreseen and otherwise!
 - Electron microscopy (TEM and LEEM/PEEM)
 - Neutron imaging
 - Nuclear power plant decommissioning
 - Mass spectrometry
 - Adaptive optics
 - Dosimetry in space
 - Gas detectors
 - Teaching science



Medipix2 – charge sharing



Simulated Data

Si 300mm, 55mm pixel

10keV monochromatic photon beam

Charge diffusion produces "charge sharing" tail

Threshold variations produce noise in image





Medipix3 – charge summing concept





Medipix3 Cell Schematic





Medipix3 Cell Layout



- 1. Preamplifier
- 2. Shaper
- 3. Two discriminators with 4-bit threshold adjustment
- 4. Configuration bits
- **5. Arbitration logic for charge allocation**
- 6. Control logic
- 7. Configurable counter.



Medipix3 - regular pixel structure





Medipix3 – spectroscopic performance



Fluorescence photons from various elements

Spectra taken by summing all counts in the chip at different thresholds and then differentiating wrt energy

Suppression of charge sharing tale is evident



Pixel scan with microfocused beam

SPM and CSM

Sum of counts recorded in all neighboring pixels as a function of beam position in x and y X-ray: 15keV; Threshlold: 7.5 keV



CSM; 50% threshold; 15 keV X-rays; SUM Beamy position [µm] Beam x position [µm]

In CSM every photon is counted

Courtesy Eva Gimenez-Navarro





Imaging with Medipix3



X-ray tube at 40kV, 40mA

0.5% pixels masked in equalization algorithm (~320)

Flat field corrected

Unexpectedly high pixel-to-pixel mismatch degrades hit allocation logic in CSM Effect being studies by design team





Imaging with Medipix3



Image of a leaf with Fe⁵⁵ source 930 e⁻ minimum threshold in SPM Very long exposure time





Moore's law - transistor feature size





Moore's Law - components per chip



SIA Roadmap 1999



- More and more functionality can be packed into a pixel
- Transistor matching for a fixed area and therefore pixel-to-pixel matching improves
- The cost/unit area of Si is more-or-less constant
- However, prototyping costs are increasing
- Power management becomes an issue



Future Challenges

In HEP :

Reduce material budget for inner layers Tracking input to trigger Data driven architectures - LHCb VELO upgrade

X-rays and other particle imaging : Improve sensor material uniformity/availability

In General :

Reduce cost per unit area – bump bonding Improve yield – single 4-side buttable tiles - TSV



Future Challenges – edgeless sensors 1



 $\begin{array}{l} 150 \ \mu m \ Si \\ 50 \ \mu m \ edge \end{array}$

J. Kaliopuska, VTT, Finland



ENIG UBM on Test Vehicle Chips

- SEM pictures of ENIG UBM pads on test vehicle chips are presented below.
 - UBM diameter ~ 27 μ m, height 4 μ m
- Picture on the left, a single ENIG UBM pad.
- Picture on the right taken with Angle-Selected Backscattered (AsB) mode.
 - Heavy elements (Ni UBM pads) are shown as brighter colours





ENEPIG UBM Tests with Timepix Wafers

- Test vehicle wafers were used for gathering statistics from FC assemblies.
- Real CMOS wafers processed with ENEPIG was feasibility test.
- ENEPIG UBM was grown on Timepix wafers with two different pitches
 - 55 μm without photoresist mask
 - 110 μm with photoresist masking. Chips were electrically measured after EN process no degradation in electrical performance.
- Electrical testing is not completed yet. Flip chip test are still needed!





PacTech Movie





Solder Ball Placement Test



First solder ball placement test on a Timepix chips



TSV development with VTT, Finland



TSVs etched by VTT on dummy wafer with 100 μm pitch



TSV development IMEC



TSVs etched IMEC in context of RelaxD project



Example of stacked chips







Flat panel X-ray

- Relaxd
- To develop a 4-side buttable tile for flat panel X-ray detectors
- Partners: PANalytical, Canberrra, IMEC, Nikhef





Future Challenges – edgeless sensors 2



J. Visser et al, Nikhef



Future Challenges – edgeless sensors 2



-64-



Carbon nano-fiber (CNF)

- Smoltek has delivered the first CERN test vehicle chips with CNF's
- We are looking into a common project for developing ultra-high-density (ultra low mass) flip chip process with CNF's.
- CNF's were deposited at 400 °C (a relatively low-temperature process)
- Test samples were analyzed and process issues were identified
 - \rightarrow new process tests with improved cycle coming in early summer
- Smoltek will make offer for work on test vehicle and real devices.



CNF forests on CERN test



Conclusions and Future Work

- Hybrid pixel detectors were developed to answer specific 'imaging' needs in HEP experiments:
 - Provide clean fast 'images' at LHC
- The Medipix Consortia have broken new ground in terms of pixel size and sophistication
- The device has been applied to many varied imaging applications
- Future challenges include:
 - Reduced material in HEP (sensor thickness, ASIC threshold
 - Reducing cost of bump bonding covering
 - Improving yield with 4 side buttable tiles
 - 3D stacking?large